



Introductory Comments

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Date: 4 January 2005



Ingrid C. Mallory

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Raanan Y. ZEHAVI et al. **Attorneys Docket:** 3816.06-C1

Serial No.: 10/829,641 **Confirmation No.:** 6952

Filed: April 22, 2004 **Art Unit No.:** 2818

Examiner: R. Berry

For: "SILICON FIXTURE SUPPORTING SILICON WAFERS DURING HIGH TEMPERATURE PROCESSING"

Commissioner for Patents
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 CFR §1.111

Sir:

In response to the Office Action of October 5, 2004, please amend the above application as follows:

01/18/2005 ZJUHAR1 00000020 10829641

01 FE:2814 65.00 QP
02 FC:2202 32.00 DA 18.00 QP